

UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.uspto.gov

DATE MAILED: 11/12/2004

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/718,828	11/21/2003	Michael Kozhukh	042390.P11082D	1333
7590 11/12/2004			EXAMINER	
Michael A. Bernadicou			NGUYEN, HUNG	
BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP			ART UNIT	PAPER NUMBER
Seventh Floor 12400 Wilshire Boulevard			2851	
Los Angeles, CA 90025			DATE MAILED: 11/12/2004	

Please find below and/or attached an Office communication concerning this application or proceeding.

,		Mc	
	Application No.	Applicant(s)	
	10/718,828	KOZHUKH, MICHAEL	
Office Action Summary	Examiner	Art Unit	
	Hung Henry V Nguyen	2851	
The MAILING DATE of this communication Period for Reply	appears on the cover sheet with	the correspondence address	
A SHORTENED STATUTORY PERIOD FOR RE THE MAILING DATE OF THIS COMMUNICATIO - Extensions of time may be available under the provisions of 37 CFF after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a - If NO period for reply is specified above, the maximum statutory per - Failure to reply within the set or extended period for reply will, by stany reply received by the Office later than three months after the meanned patent term adjustment. See 37 CFR 1.704(b).	N. R 1.136(a). In no event, however, may a repl reply within the statutory minimum of thirty (riod will apply and will expire SIX (6) MONTH atute, cause the application to become ABAN	y be timely filed 30) days will be considered timely. S from the mailing date of this communication. IDONED (35 U.S.C. § 133).	
Status		•	
 1) Responsive to communication(s) filed on P 2a) This action is FINAL. 2b) 1 3) Since this application is in condition for allo closed in accordance with the practice under th	This action is non-final. wance except for formal matter	s, prosecution as to the merits is	
Disposition of Claims			
4) ☐ Claim(s) <u>26-31</u> is/are pending in the application 4a) Of the above claim(s) is/are with the state of the above claim(s) is/are with the state of the state of the application of the application of the application and state of the application and application and application and application and application and application of the application and application of the application and application of the application and application application and application application and application application and application appli	drawn from consideration.		
Application Papers			
 9) The specification is objected to by the Exam 10) The drawing(s) filed on 21 November 2003 Applicant may not request that any objection to Replacement drawing sheet(s) including the cor 11) The oath or declaration is objected to by the 	is/are: a)⊠ accepted or b)⊡ o the drawing(s) be held in abeyance rection is required if the drawing(s)	s. See 37 CFR 1.85(a). is objected to. See 37 CFR 1.121(d).	
Priority under 35 U.S.C. § 119			
12) Acknowledgment is made of a claim for fore a) All b) Some * c) None of: 1. Certified copies of the priority docum 2. Certified copies of the priority docum 3. Copies of the certified copies of the papplication from the International Bur * See the attached detailed Office action for a	ents have been received. ents have been received in Apportiority documents have been re reau (PCT Rule 17.2(a)).	elication No ceived in this National Stage	
Attachment(s)	_		
 Notice of References Cited (PTO-892) Notice of Draftsperson's Patent Drawing Review (PTO-948) Information Disclosure Statement(s) (PTO-1449 or PTO/SB Paper No(s)/Mail Date 11/03. 		nmary (PTO-413) Mail Date rmal Patent Application (PTO-152)	

U.S. Patent and Trademark Office PTOL-326 (Rev. 1-04) Application/Control Number: 10/718,828

Art Unit: 2851

DETAILED ACTION

Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in a patent granted on an application for patent by another filed in the United States before the invention thereof by the applicant for patent, or on an international application by another who has fulfilled the requirements of paragraphs (1), (2), and (4) of section 371(c) of this title before the invention thereof by the applicant for patent.

The changes made to 35 U.S.C. 102(e) by the American Inventors Protection Act of 1999 (AIPA) and the Intellectual Property and High Technology Technical Amendments Act of 2002 do not apply when the reference is a U.S. patent resulting directly or indirectly from an international application filed before November 29, 2000. Therefore, the prior art date of the reference is determined under 35 U.S.C. 102(e) prior to the amendment by the AIPA (pre-AIPA 35 U.S.C. 102(e)).

2. Claims 26-31 are rejected under 35 U.S.C. 102(e) as being anticipated by Sandstrom et al (U.S.Pat. 6,624,880).

With respect to claims 26-30, Sandstrom et al discloses an micro lithography and corresponding method comprising all of the limitations of the instant claim such as: providing a reflective liquid crystal display (30) having an array of configurable pixels (col.3, lines 54-60); functioning as a mask for forming any predetermined patterns including a first image pattern and a second pattern on the reflective liquid crystal display; a radiation (10) for directing radiation from a radiation source onto the reflective liquid crystal display thereby generating a first and second reflected radiation patterns/or generating a continuously varying reflected radiation pattern (see col.7, lines 38-49, lines 55-59 and col.8, lines 1-10); a projection optical system

(col.5, lines 38-63) for reducing and projecting the first and second reflected radiation patterns onto a substrate (60).

As to claim 31, Sandstrom et al further disclose the radiation source being an optical light source, an ultraviolet light source, an excimer laser, an x-ray source, an electron source, or an ion source (see col.7, lines 50-59).

Prior Art Made of Record

3. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Lin (U.S.Pat. 6,215,578); Marle (US 2002/0171816 A1) and Fries (U.S.Pat. 6,544,698) discloses Maskless pattern generation photolithography system and have been cited for technical background.

- 4. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Hung Henry V Nguyen whose telephone number is 571-272-
- 2124. The examiner can normally be reached on Monday-Friday (First Friday off).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Judy Nguyen can be reached on 571-272-2258. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Art Unit: 2851

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

^VHung Henry V Nguyen Primary Examiner Page 4

Art Unit 2851

hvn 11/6/04